



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu KOBAYASHI

Group Art Unit: 2871

Application No.: 10/722,448

Examiner:

Filed: November 28, 2003

Docket No.: 117830

For: ELECTROLUMINESCENT DISPLAY DEVICE, METHOD FOR MANUFACTURING
THE SAME, AND ELECTRONIC EQUIPMENT

INFORMATION DISCLOSURE STATEMENT

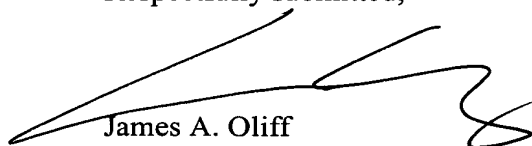
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 3. English language Abstracts of the non-English language references are attached hereto.

Respectfully submitted,

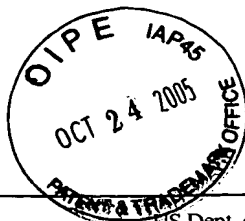

James A. Oliff
Registration No. 27,075

Gang Luo
Registration No. 50,559

JAO:GXL/sqb
Date: October 24, 2005

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--

Sheet 1 of 1

Form PTO-1449 (REV. 8-83) US Dept. of Commerce PATENT & TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		ATTY DOCKET NO. 117830		APPLICATION NO. 10/722,448		
		APPLICANT Hidekazu KOBAYASHI				
		FILING DATE November 28, 2003		GROUP 2871		
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	1	2002/0043934 A1	04/18/2002	Taizou TANAKA		
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	2	KR2002-0030726A (Corresponding to U.S. 2002/0043934 A1 and JP A 2002-198187)	04/25/2002	Korea		
	3	JP A 2002-198187 (w/Eng Abstr)	07/12/2002	Japan		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
	4	Ching-Ting LEE et al., "Effects of Plasma Treatment on the Electrical and Optical Properties of Indium Tin Oxide Films Fabricated by R.F. Reactive Sputtering", THIN SOLID FILMS, Vol. 386, 2001, pages 105-110				
EXAMINER				DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						

Date: October 24, 2005